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1-2-02
ATTORNEY DOCKET NO. 43889-929 *Rad*
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Toyokazu FUJII, et al.) Group Art Unit: 2814
Serial No.: 09/536,618) Examiner: H. PHAM
(DIV of SN: 09/018,181))
Filed: March 26, 2000)
For: SEMICONDUCTOR DEVICE AND PROCESS)
FOR FABRICATION OF THE SAME)

RECEIVED
DEC 28 2001
TECHNOLOGY CENTER 2800

AMENDMENT UNDER 37 C.F.R. § 1.111

Hon. Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action dated September 26, 2001, having a shortened statutory period for response set to expire December 26, 2001, please amend the above-identified application as follows:

IN THE TITLE:

Please amend the title of the invention to read as --A SEMICONDUCTOR
B1 DEVICE HAVING IMPROVED PLANARIZATION PROPERTIES AND A METHOD FOR
FORMING THE SAME--.